



**ELECTRONIC COPY**

LG713598272  
Report verification at igi.org



June 17, 2025

IGI Report Number **LG713598272**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **7.93 X 5.41 X 3.57 MM**

**GRADING RESULTS**

Carat Weight **1.34 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

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MODIFIED BRILLIANT**

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Color Grade **E**

Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

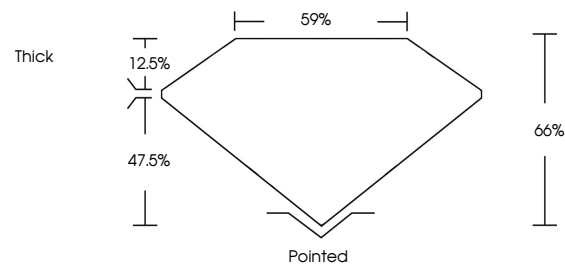
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG713598272**

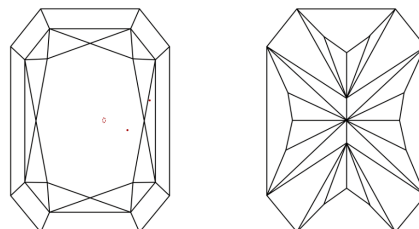
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

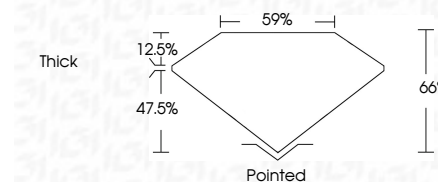
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



June 17, 2025	IGI Report No LG713598272	CUT CORNERED RECT. MODIFIED BRILLIANT	1.34 CARAT	E	VVS 2	66%	59%	Thick	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG713598272
7.93 X 5.41 X 3.57 MM	Carat Weight	Color Grade	Clarity Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)		

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Type IIa